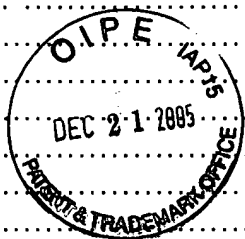


IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. .... 10/624,340  
Confirmation No. .... 6987  
Filing Date ..... July 21, 2003  
Inventor ..... Brent A. McClure  
Assignee. .... Micron Technology, Inc.  
Group Art Unit ..... 2831  
Examiner ..... N. Ha  
Attorney's Docket No. .... MI22-2067  
Customer No. .... 021567  
Title: ..... Capacitor Constructions and Methods of Forming



SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

**References – See Attached Form PTO-1449**

The Examiner's attention is directed to the references which are listed on the attached Form PTO-1449. Pursuant to 37 C.F.R. §1.98(a)(2)(1) no copies of any cited U.S. patents or U.S. published applications are included herewith. Copies of all other cited art references, if any, are attached. No admission is made regarding whether all the submitted references are prior art.

Citation of the referenced art is respectfully requested.


12/28/2005 DTESSEM1 00000044 10624340

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180.00 OP

Respectfully submitted,

Dated: 21 Dec 2005

By:   
James E. Lake  
Reg. No. 44,854

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-2067	SERIAL NO. 10/624,340		
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary) <div style="position: absolute; top: 50px; left: 50px; border: 2px solid black; border-radius: 50%; padding: 10px; text-align: center;">             OFFICE              DEC 21 2005              PATENT &amp; TRADEMARK OFFICE           </div>				APPLICANT: Brent A. McClure et al.			
				FILING DATE July 21, 2003		GROUP 2831	
<b>U.S. PATENT DOCUMENTS</b>							
*Examiner's Initials	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
AA	2005/0082593 A1	04/2005	Lee et al.				
AC	6,824,816	11/2004	Aaltonen et al.				
AD	6,307,730	10/2001	Yamanishi				
AF	5,811,344	09/1998	Tu et al.				
AG	6,596,583	07/2003	Agarwal et al.				
AH	6,069,053	05/2000	Ping et al.				
AI	6,033,967	03/2000	Li et al.				
AJ	5,885,882	03/1999	Schugraf et al.				
AK	6,174,770	01/2001	Chi, Min-hwa				
AL							
AM							
<b>FOREIGN PATENT DOCUMENTS</b>							
	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
AN							
AO							
AP							
<b>OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)</b>							
	AQ						
	AR						
EXAMINER		DATE CONSIDERED					
<small>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</small>							

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